

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination SUZUKI ET AL.	
		Examiner Darcy D. LaClair	Art Unit 1796	Page 1 of 1

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-2004/0147660	07-2004	Ishida et al.	524/442
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N	WO 03010091 A1	02-2003	World Intellect	ENOKI H et al.	C08K 3/34
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S					
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NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	Lenntech (1998) Silicon (Si) and Water: Reaction Mechanisms Online at: http://www.lenntech.com/periodic/water/silicon/silicon-and-water.htm
V	
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X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
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